Electronic Acknowledgement Receipt FES ID: 1043382 Application Number: 09941827 Confirmation Number: 7551 Method of improved high K dielectric-polysilicon interface for CMOS Title of Invention: First Named Inventor: Ronald A. Weimer Customer Number: 31870 Filer: Kristine M. Strodthoff/Jere Polmatier Filer Authorized By: Kristine M. Strodthoff Attorney Docket Number: MTI-31532 Receipt Date: 10-MAY-2006 Filing Date: 29-AUG-2001 Time Stamp: 11:00:26 Application Type: Utility International Application Number:

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File Listing:

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Document Number	Document Description	File Name	File Size(Bytes)	Multi Part	Pages
1		OfficeActionResponse51006.	880131	yes	31

	waitipart Description			
	Doc Desc	Start	End	
	Amendment - After Non-Final Rejection	1	1	
	Claims	2	28	
	Applicant Arguments/Remarks Made in an Amendment	29	31	
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New Applications Under 35 U.S.C. 111

If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

National Stage of an International Application under 35 U.S.C. 371

If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.